

# Gas Density Measurement for Self-modulation Experiment at PITZ

- > Self-Modulation
- > Methods of gas density measurement
- > Progress in gas density measurement
- > Summary

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**DPG Spring meeting 09-13 March, 2015**



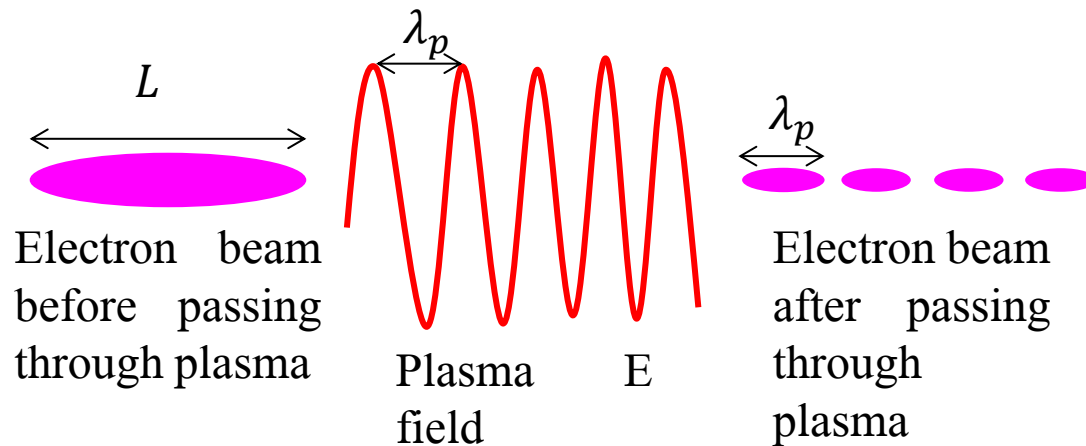
# Self-modulation

A proton driven plasma wakefield acceleration experiment was proposed by A.Caldwell et al. in 2009.

The CERN SPS bunch has length  $\sim 12\text{cm}$  (120mm), but short ( $<1\text{mm}$ ) bunches are needed for efficient acceleration.

How to generate short proton bunches?

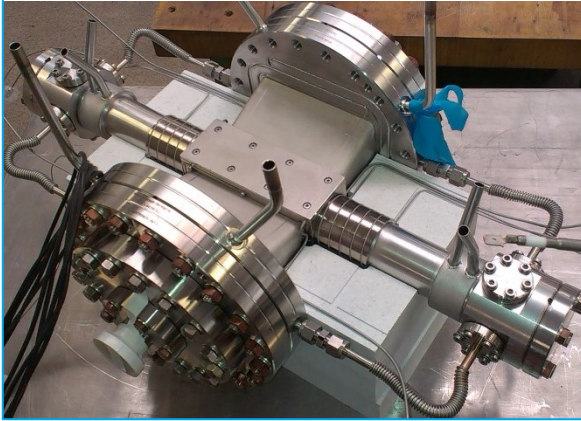
To generate short proton bunches a technique viz. self modulation was proposed by N. Kumar and A. Pukhov in 2010.



A long ( $L > \lambda_p$ ), relativistic particle beam propagating in an overdense plasma is subject to the self-modulation instability via transverse wakefields of a plasma wave.

# Self-modulation at PITZ

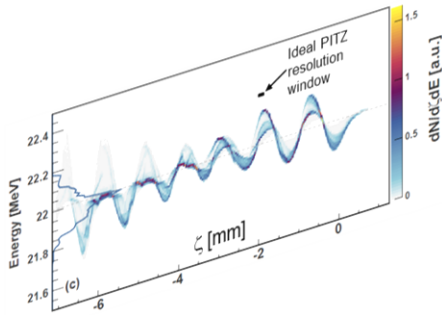
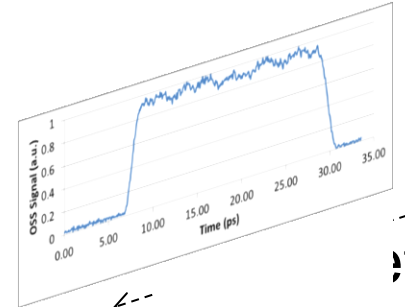
Fabricated Cell



Cooling Sleeve

Li Gas  $\approx 10^{15} \text{ cm}^{-3}$

Thermal Insulation



Electron Window

Helium Distribution

Ionization Laser Path

Laser Window

Heating Coils

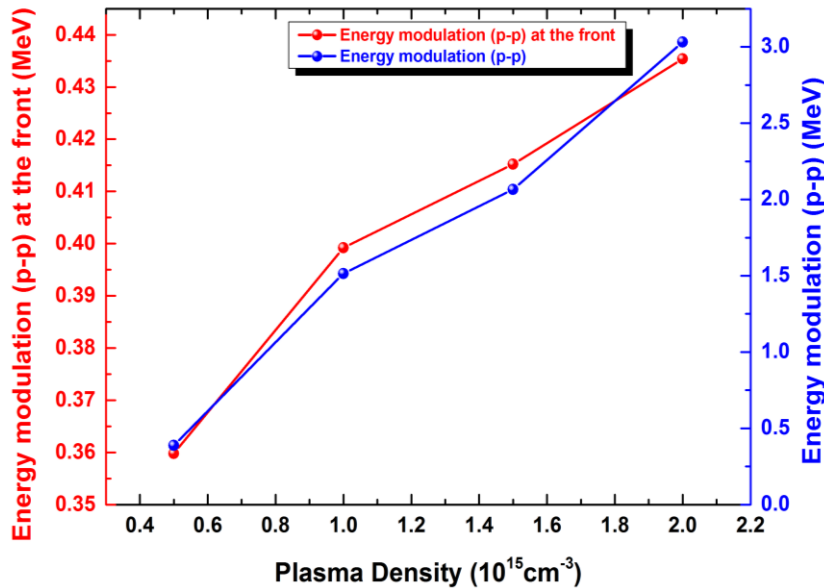


Design:  
Gerald Koss

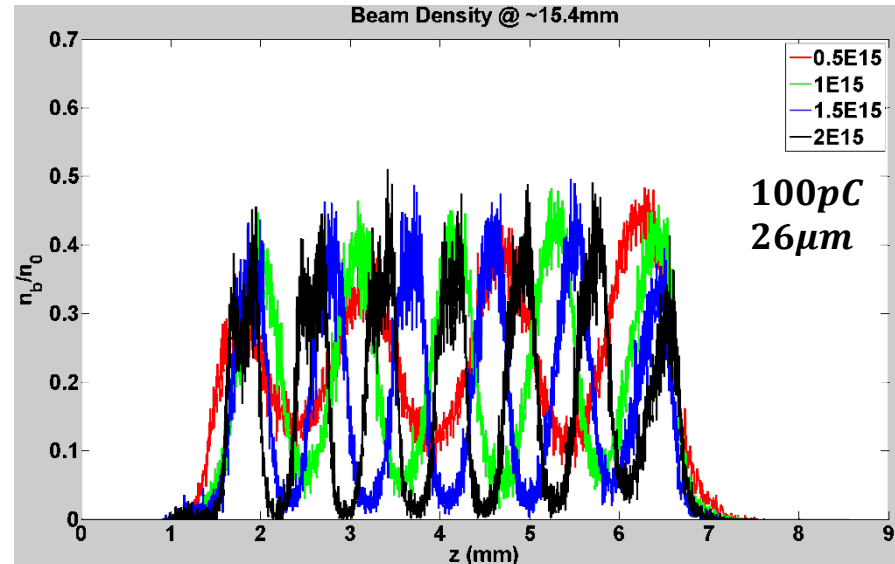


# Effect of Plasma Density Variation

$$\lambda_p = 1\text{mm} \sqrt{\frac{10^{15}\text{cm}^{-3}}{n_p}}, \lambda_p(\text{mm}) = \begin{cases} 1.414 & \text{for } 0.5 \times 10^{15}\text{cm}^{-3} \\ 1 & \text{for } 10^{15}\text{cm}^{-3} \\ 0.816 & \text{for } 1.5 \times 10^{15}\text{cm}^{-3} \end{cases}$$



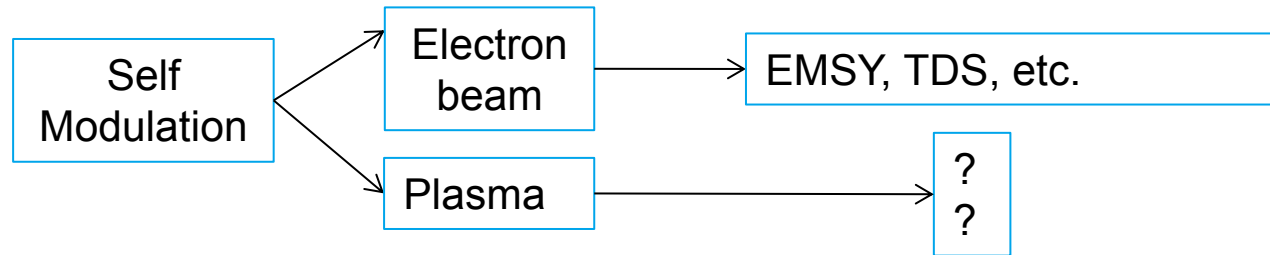
Plasma density vs Energy modulation with beam size fix at  $\sim 26\mu\text{m}$  and beam charge 100pC



Beam density modulation with beam size fix at  $\sim 26\mu\text{m}$  and beam charge 100pC

# Methods of Density Measurement

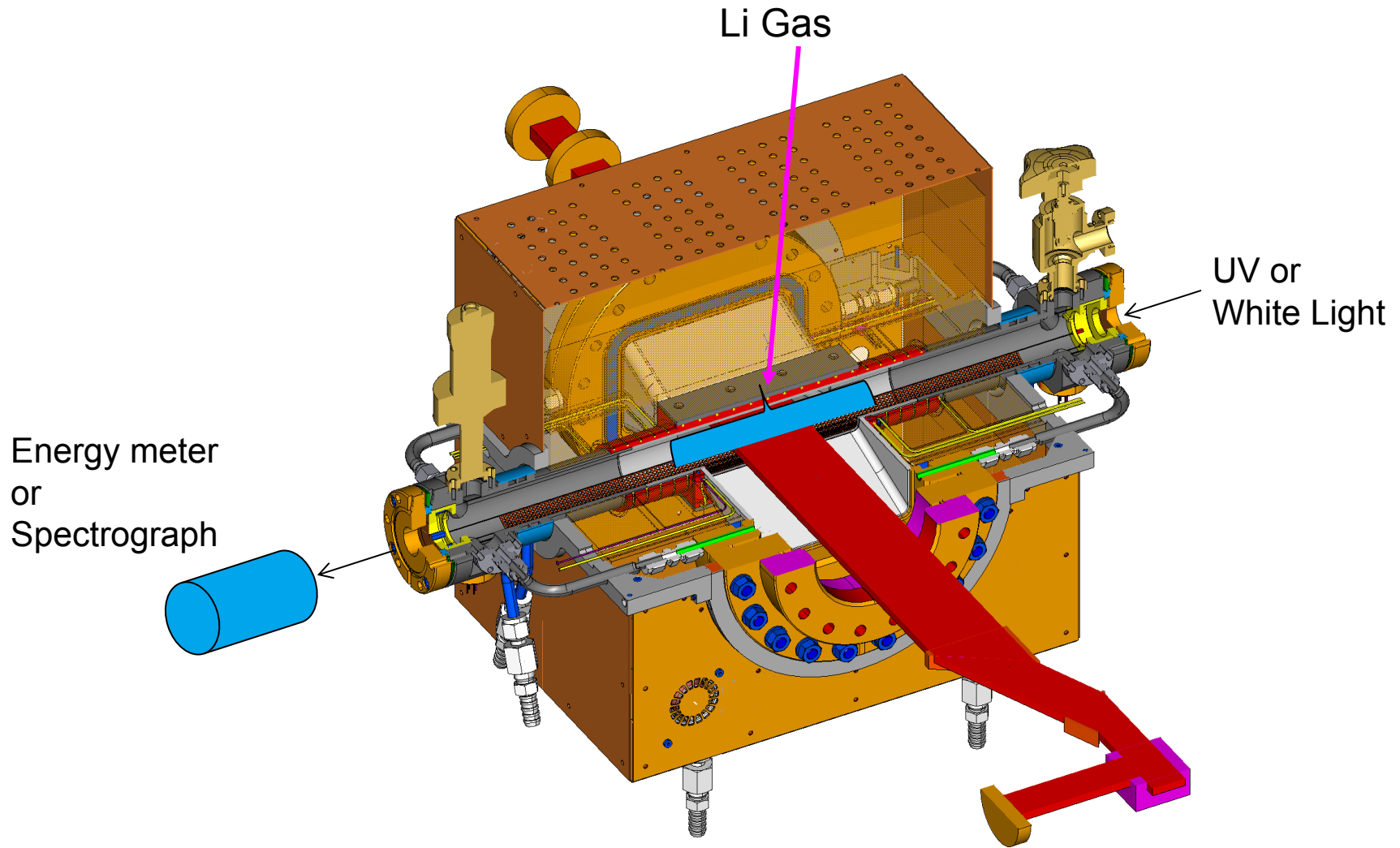
1) Plasma:



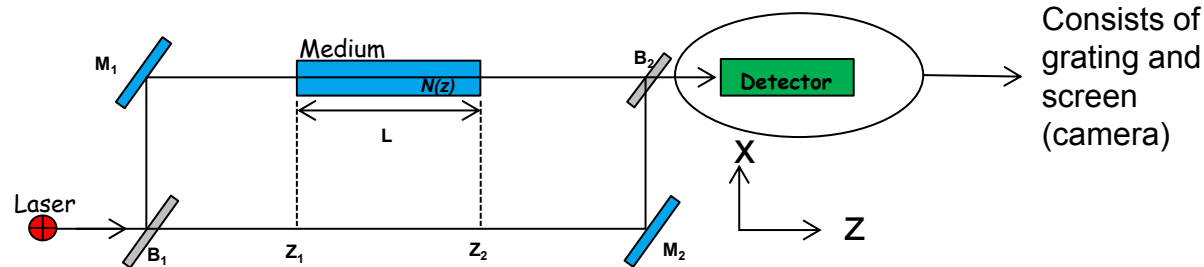
2) Gas:

Measurement	Principle	Density relation
UV absorption	A low energy laser pulse will be sent to the gas. The absorption will be recorded at the end.	$n_0 L = -\frac{1}{\sigma} \ln\left(\frac{E_{transmitted}}{E_{incident}}\right)$
White light absorption	Strong transition of Li first excited state to second leads to determine the density.	Absorption coefficient $\gamma(\omega) \propto n_0$
Hook Method	Hooks formed at white light interference pattern are related to gas density.	$n_0 L \propto \Delta^2$ $\Delta = \text{hook distance}$

# UV and White Light Absorption

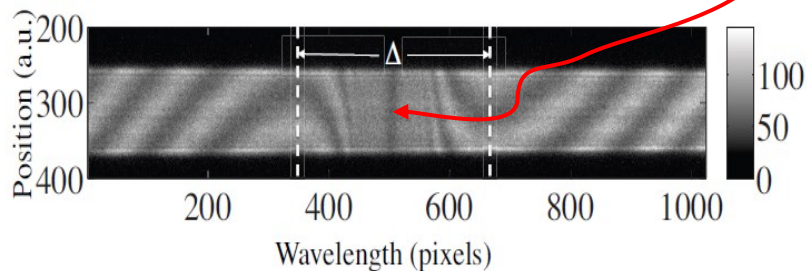


# Hook method for gas density measurement



Hook method: Mach-Zehnder interferometer

**Hook Method:** The **grating** disperses the fringes with different wavelengths  $\lambda_i$  in different x-directions. Because of the wavelength-dependent refractive index  $n(\lambda)$  of the atomic vapor the fringe shift follows a **dispersion curve** in the vicinity of the **absorption spectral line**. The dispersed fringes look like hooks around an absorption line, which gave this technique the name hook method (Fig. 1).



$$n_e \propto \Delta^2$$

Fig. 1: Hook interferogram (current figure is for Rubidium vapor, courtesy: E. Öz, IPAC 2014 )

# Calibration of diffraction grating for hook method

Used for calibration of the diffraction grating:

- 1) Two lasers of slightly different wavelengths  $\lambda_1$  and  $\lambda_2$ .
- 2) Screen (camera).

Diffraction equation:

$$d \sin \theta = m\lambda$$

$d$ : grooves spacing in the grating

$\theta$ : angle of diffraction for a particular  $\lambda$

$m$ : order of diffraction

$$\theta = \sin^{-1} \left( \frac{\lambda_{\mu m}}{1.66} \right)$$

$$m = 1, d = 1.66 \mu m$$

Angle of diffraction for the two lasers:  $\theta_1$  and  $\theta_2$

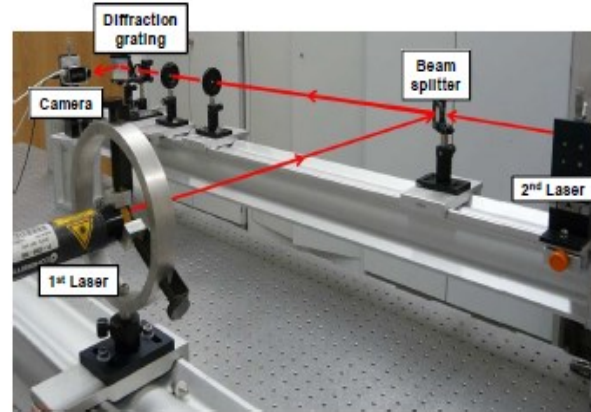
Distance between grating and screen:  $x$

Difference between first order diffraction for both wavelengths:

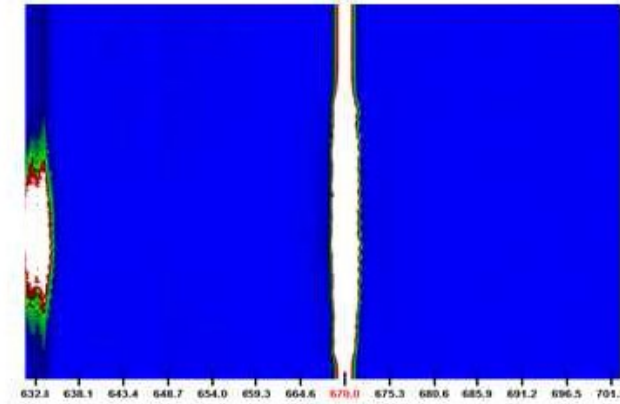
$$\Delta y = x(\tan \theta_1 - \tan \theta_2)$$

and hence

$$\Delta y = \lambda_1 - \lambda_2$$



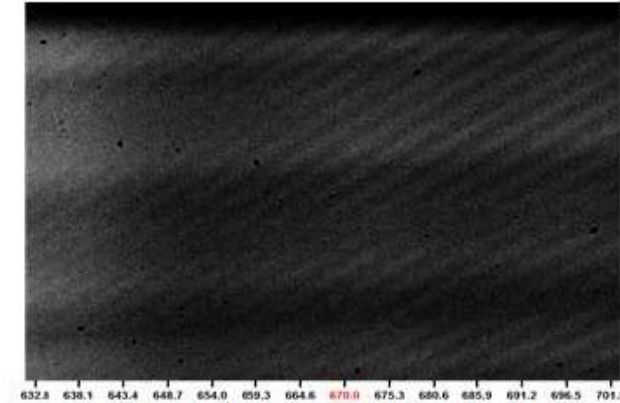
Calibration setup for diffraction grating



First order diffraction for the 670nm and 632.8nm



Diffraction pattern for the 670 nm and 632.8 nm. From right to left 0<sup>th</sup>, 1<sup>st</sup>, 2<sup>nd</sup> ... order diffraction pattern. 0<sup>th</sup> order diffraction overlaps for both lasers because it is just a reflection from grating.



Wavelength distribution of white light interference

The calibration achieved by this method is 0.05 nm/pixel or 11.34 nm/mm



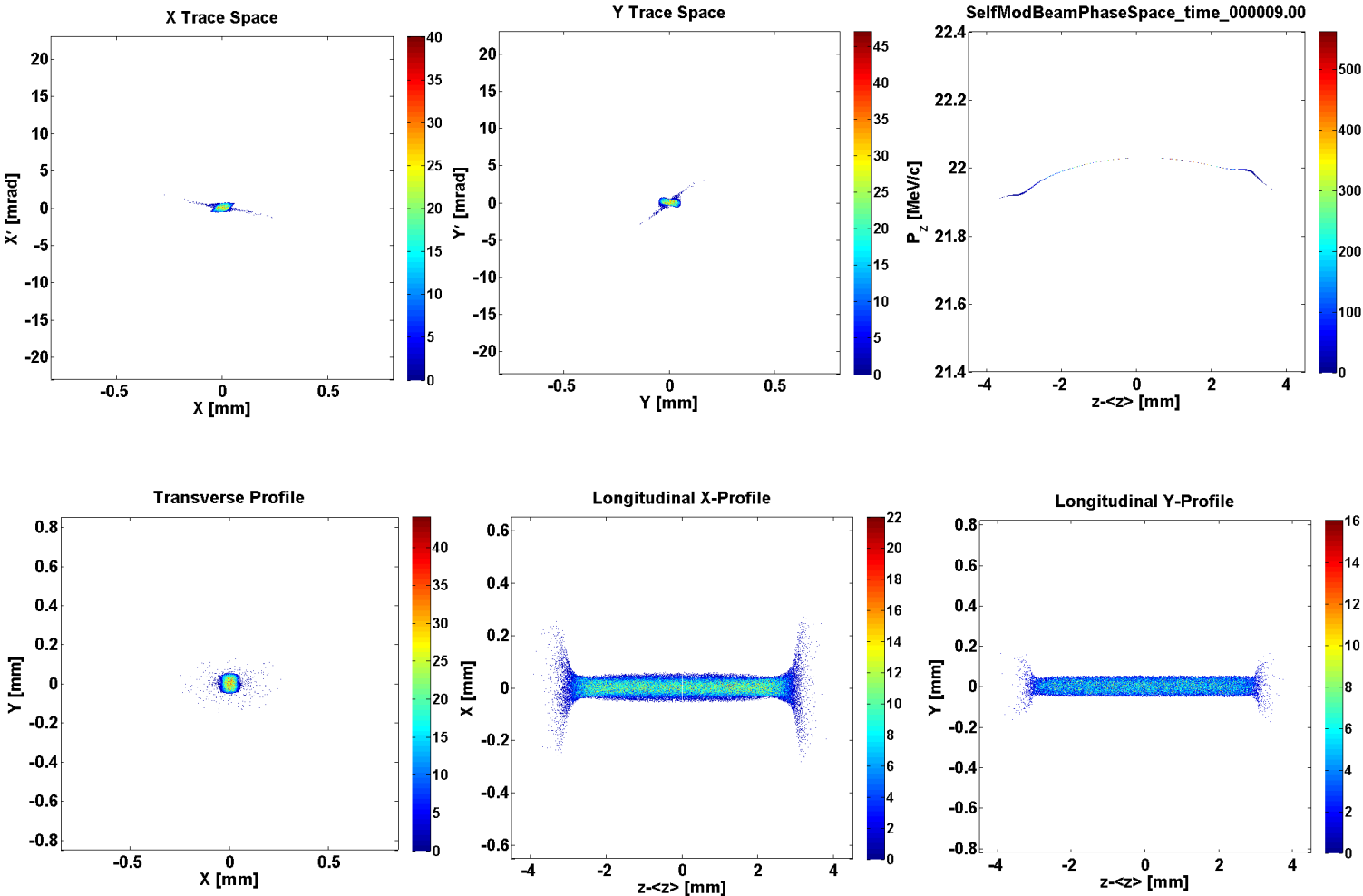
# Summary

- Lithium gas density for PITZ plasma experiment will be measured with Hook method.
- Calibration has been done for diffraction grating using two lasers and it comes out to be 0.05 nm/pixel or 11.34 nm/mm.
- Expected gas density:  $\sim 10^{15} \text{ cm}^{-3}$  - can be measured with this method.
- Plasma density will be measured by different methods as well.

## Thank you

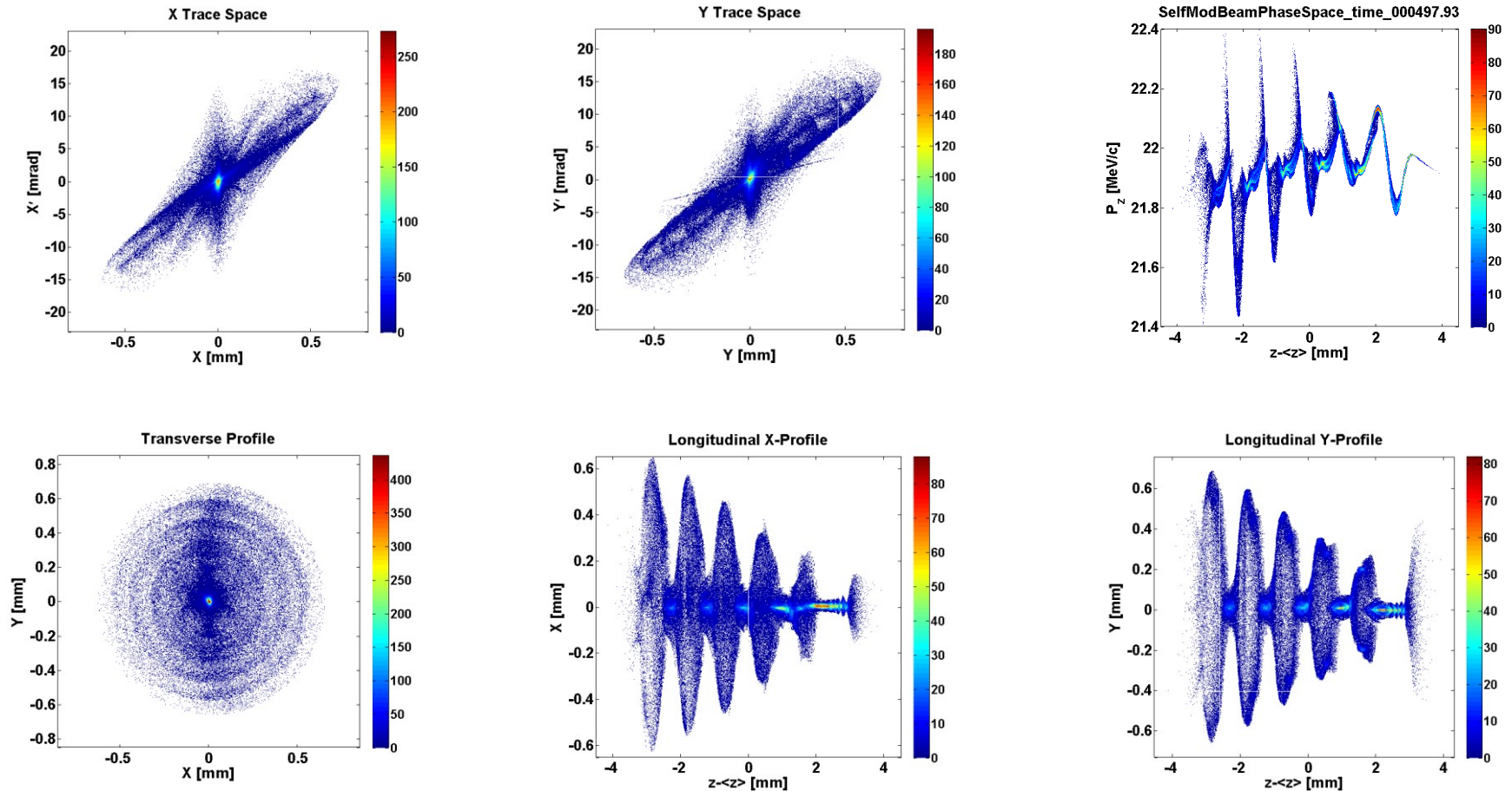
# Back up for simulations

# Beam properties before plasma



$$\begin{aligned}
 x' &= 1.6 \text{ mrad} \\
 y' &= 1.6 \text{ mrad} \\
 p_z^{\text{mean}} &= 22 \text{ MeV}/c \\
 p_z^{\text{rms}} &= 22 \text{ MeV}/c \\
 x_{\text{rms}} &= 27 \mu\text{m} \\
 y_{\text{rms}} &= 26 \mu\text{m} \\
 \varepsilon_x &= 0.370 \text{ mm mrad} \\
 \varepsilon_y &= 0.375 \text{ mm mrad}
 \end{aligned}$$

# Beam properties after plasma



Divergence increase  $\sim 1$  order

Modulation is observed more in the tail of beam.

Beam is compressed transversely due to strong transverse focusing force of plasma.

Different compression in x, y direction is due to asymmetrical transverse beam size.

To decrease divergence  $\rightarrow$  Beam matching **can be** applied

# Beam matching phenomena

Purpose of beam matching:

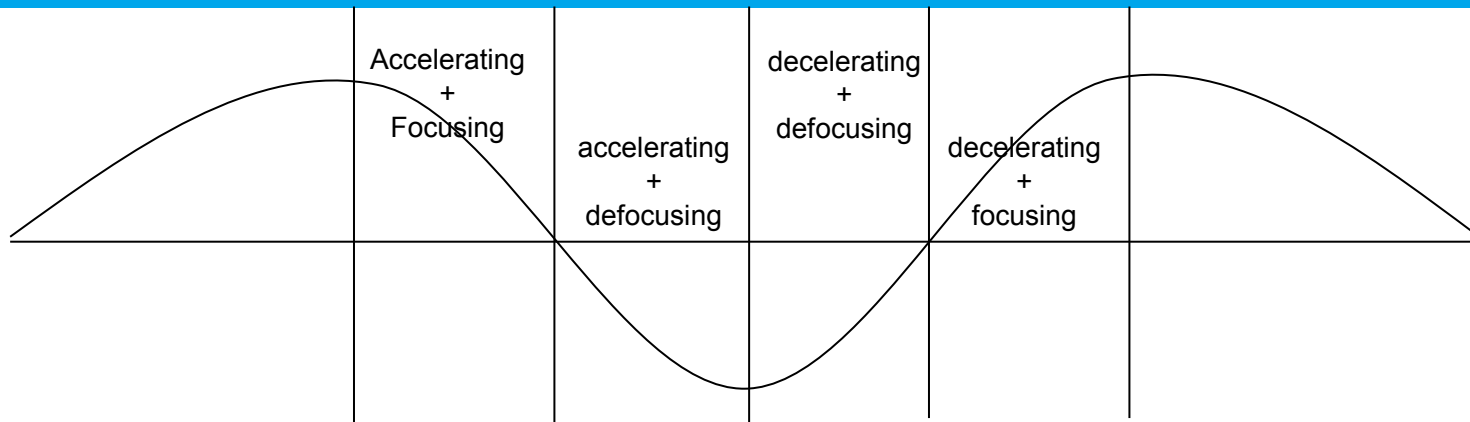
- > Acceleration of the bunch of charges particles to high energies requires **synchronization** and **phase focusing**

The synchronization is achieved by matching the rf or plasma frequency with particle velocity

The Phase focusing is achieved by matching a proper phase angle between the rf-wave and the beam bunch

**Prevent emittance growth**

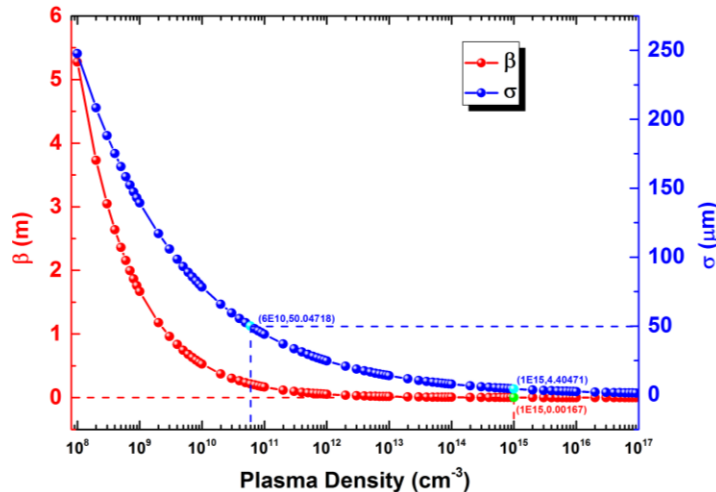
# Beam matching for plasma accelerators



Beam matching for blowout regime

$$\beta_m \approx \frac{c}{\omega_\beta}, \gamma_m \approx \frac{c}{\omega_\beta}, \alpha_m = 0$$

**synchronization**  
+  
**phase focusing**  
+  
**Maximize the E field**



- For beam matching with plasma density of  $10^{15} \text{cm}^{-3}$  the twiss parameter  $\beta_m$  (1.6mm) and corresponding beam size  $\sigma_r$  ( $4.5 \mu\text{m}$ ) are quite small.
- With feasible beam size ( $\sim 50 \mu\text{m}$ ) from PITZ accelerator corresponding plasma density comes out be  $6 \times 10^{10} \text{cm}^{-3}$  for matching case.
- This concludes that perfect transverse beam matching can not be achieved with “desired” beam and plasma parameters for PITZ self-modulation experiment.

# Beam matching for plasma accelerators

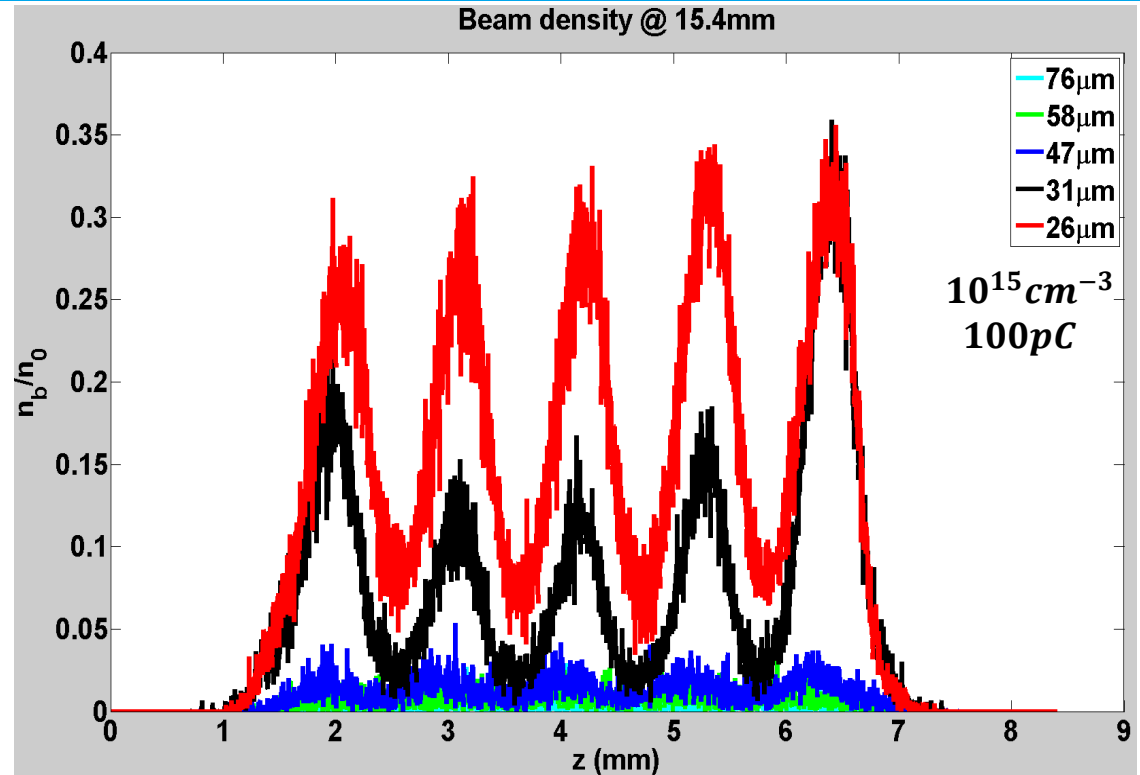
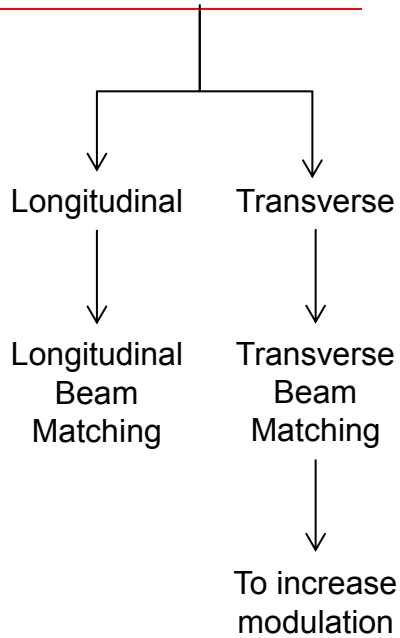
synchronization

+

phase focusing

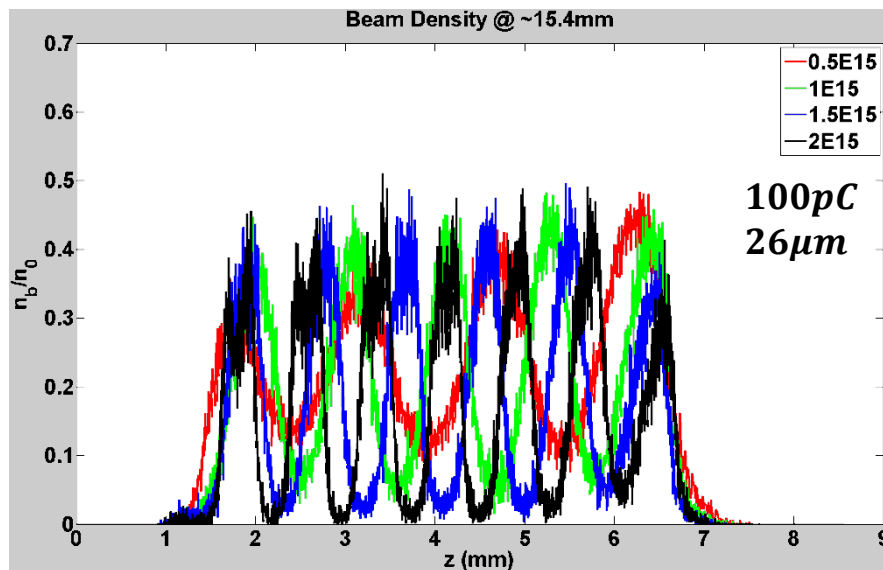
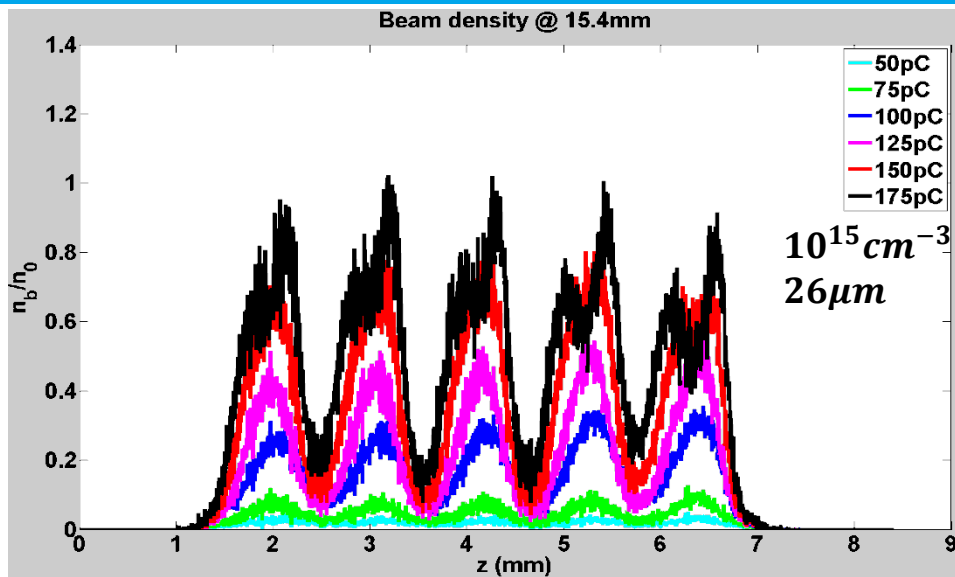
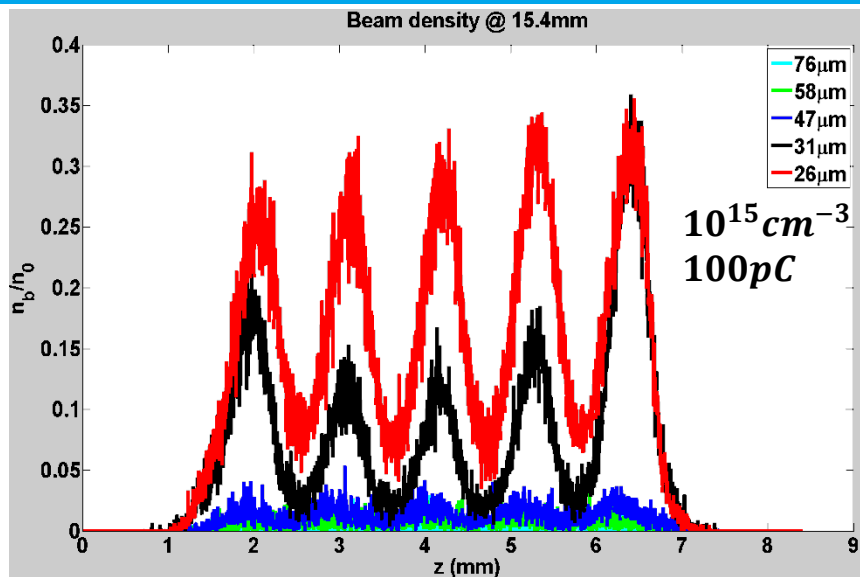
+

Maximize the E field



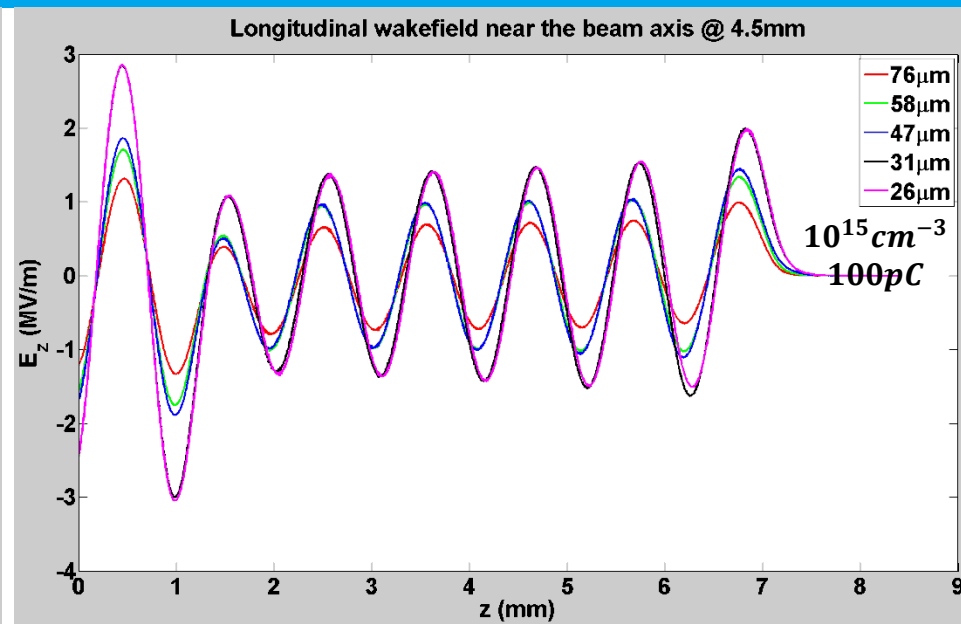
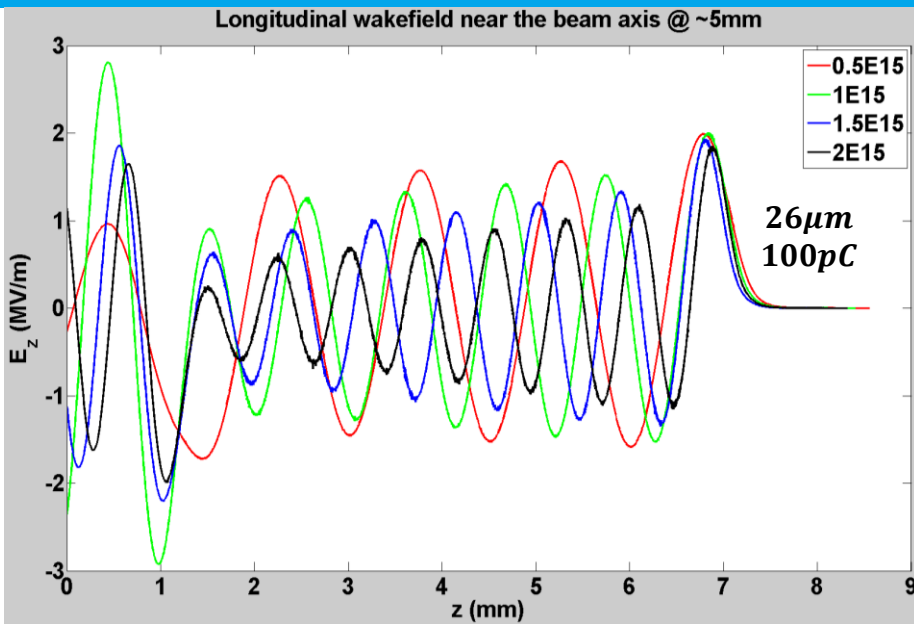
Decrease the beam size  $\rightarrow$  approach to the beam matching case

# Beam density modulation





# Longitudinal wakefield

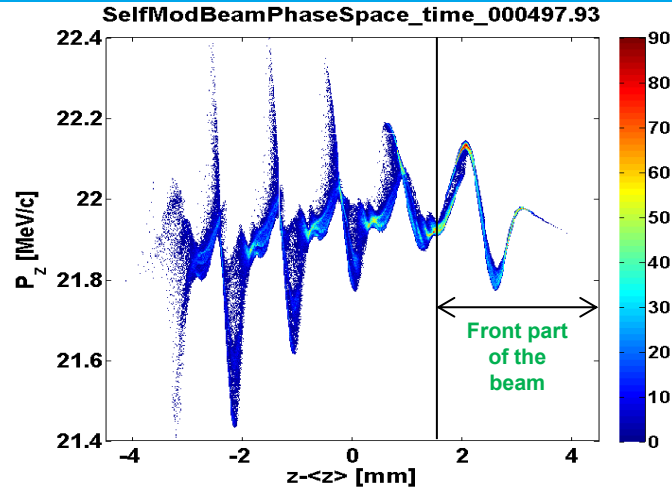


$$E_z \propto \frac{n_{b0}}{\sqrt{n_p}} \cdot R(0)$$

$$E_{focus} \propto \frac{n_{b0}}{\sqrt{n_p}} R'(\sigma_r)$$

Where  $R(0)$  is the unitless transverse component.  
Both  $R(0)$  and  $R'$  are increasing function of  $k_p \sigma_r$ .

# Optimizing the strength of the modulation



Initial Beam Parameters

$$p_z^{mean} = 22 \text{ MeV}/c$$

$$x_{rms} = 27 \mu\text{m}$$

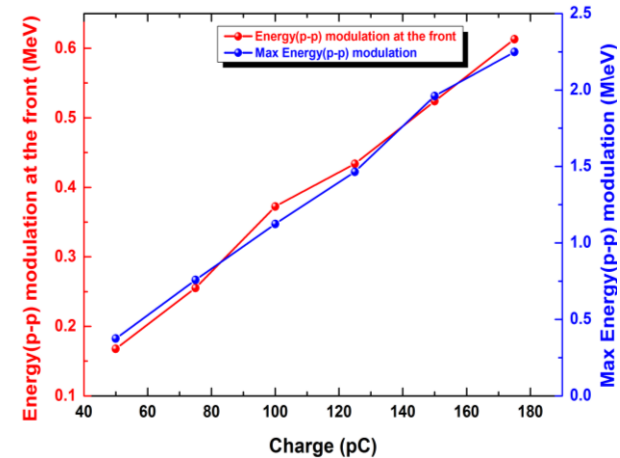
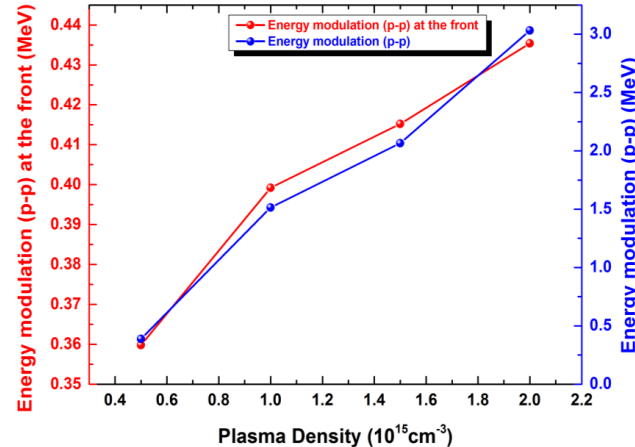
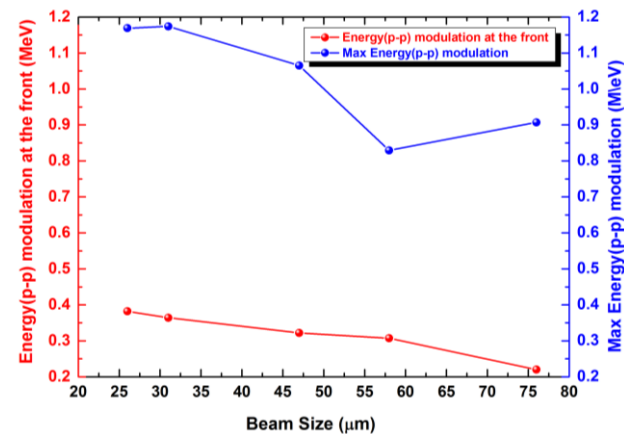
$$y_{rms} = 26 \mu\text{m}$$

$$z_{long} \approx 6 \text{ mm}$$

$$Q = 100 \text{ nC}$$

With Plasma Density

$$n_e = 10^{15} \text{ cm}^{-3}$$



Beam size vs Energy modulation with plasma density at  $10^{15} \text{ cm}^{-3}$  and beam charge 100pC

Plasma density vs Energy modulation with beam size fix at  $\sim 26 \mu\text{m}$  and beam charge 100pC

Beam Charge vs Energy modulation with plasma density  $10^{15} \text{ cm}^{-3}$  and beam size  $\sim 26 \mu\text{m}$